IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Ranish et al.

Group Art Unit: Unknown

Application No: Unknown Confirmation No: Unknown

Examiner: Unknown

Filed: Herewith

Attorney Docket No:

008341 USA/CPS/IBSS/LAP

January 6, 2003

RING FOR SUBSTRATE

San Francisco, California

PROCESSING CHAMBER

Title: THERMALLY MATCHED SUPPORT

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir/Madam:

Attached hereto is a PTO-1449 form listing documents believed relevant to the subject application. It is respectfully requested that these documents be considered by the Examiner and an initialed copy of the form be returned to the undersigned.

Applicant believes this Information Disclosure Statement should be considered by the Office because it is being filed before the mailing of a first Office Action on the merits.

It is believed that no fee is due for the filing of this Information Disclosure Statement. However, if any fee is due, the Commissioner is hereby authorized to charge payment of any such fees to Deposit Account No. 10-0258.

Also, if any Petition is required for the filing of this Information Disclosure Statement, such Petition is requested herein.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as express mail in an envelope addresser to: Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or facsimile transmitted to the U.S. Patent and Trademark Office at (703) __ on the date shown below.

By:

Date: FEB. 5, 2004

008341 USA/CPS/IBSS/LAP Appl. No. Unknown Page 2 of 2

It is believed that this disclosure complies with the requirements of 37 C.F.R. §§ 1.56, 1.97, and 1.98, and the Manual of Patent Examining Procedures §707.05(b). If for some reason the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

Except for US patents and published applications, a copy of each document is enclosed.

Some of the documents may have markings thereon. No significance is meant to be attached to the markings.

With regard to any translations which may be provided herewith, the undersigned does not know how the translations were made, or by whom the translations were made.

Therefore, no representation is being made as to the accuracy of any translation.

These documents are not necessarily analogous.

Respectfully submitted, JANAH & ASSOCIATES, P.C.

Date: 1/16/2004 By:

Ashok K. Janah Reg. No. 37,487

Please direct all telephone calls to:

Please continue to send all correspondence to:

Ashok K. Janah (415) 538-1555

Applied Materials, Inc.
Patent Department, M/S 2061
P.O. Box 450A
Santa Clara, CA 95052

Encl.

008341 USA/CPS/IBSS/

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Complete if Known Substitute for form 1449/PTO **Application Number** Unknown Filing Date Herewith INFORMATION DISCLOSURE First Named Inventor Ranish STATEMENT BY APPLICANT Art Unit Unknown (Use as many sheets as necessary) Examiner Name Unknown

Sheet 1

of 1

Attorney Docket Number

				T DOCUMENTS		
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ^{2 (f known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		^{US-} 4932358	06-12-1990	Studley et al.		
_		^{US-} 5618380	04-08-1997	Siems et al.		
		^{US-} 5723385	03-03-1998	Shen et al.		
		^{US-} 5851299	12-22-1998	Cheng et al.		
		^{US-} 5929509	07-27-1999	Shen et al.		
		^{US-} 6133152	10-17-2000	Bierman et al.		
• •		^{US-} 6608287	08-19-2003	Halpin et al		
		US-				
		US-				
		US-				
		US-				
		US-				
		US-				
		US-				
		US-				
		US-				
		US-				
		US-				
	ļ	US-				

		FORE	IGN PATENT DOCU	MENTS		
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)	MM-DD-YYYY			T ⁶
				-		
						L

Examiner		 Date		
Signature		Considere	d	
. "			-	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. Applicant's unique citation designation number (optional). See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.